

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2495		PRIORITY SERIAL NO. 10/820,575	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Scott E. Moore et al.		PRIORITY FILING DATE March 7, 2000	
						PRIORITY GROUP 2886	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA							
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation Yes No	
	AH						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
/RMP/	AI	"The Science and Engineering of Microelectronic Fabrication"; Campbell, Stephen A.; Oxford University Press: 1996, pp. 253-257.					
	AI	http://www.intratechnology.com/html/sensors.htm, Intra Technology, Sensors, 03/25/99, 2 pages					
	AI	http://www.fisinc.com/complete/analite/analite.htm, FTS, Analite-SDI Turbidity Sensor, 03/25/99, 1 page					
	AK	http://www.customsensors.com/optimax.htm, Custom Sensors & Technology, OptiMax 6000 Series Process Photoacoustic Analyzers, 03/25/99, 2 pages					
	AL	http://www.reflectronics.com/reflectronics_inc_content.htm, Reflectronics, Inc., Fiber Optic Backscatter Sensor, 03/25/99, 1 page					
	AM	http://www.honeywell.com/sensing/prodinfo/turbidity/technical/turbidity.st, Gary O'Brien, Honeywell, Turbidity Sensor for Electromechanical Dishwasher Control, 1998-1999, 11 pages					
/RMP/	AT	http://www.impmag.com/O_automa10970054.htm, ABB Instrumentation, The Stockroom, Photodiode Sensor, 1999, 1 page					
EXAMINER /Roy M. Punnoose/				DATE CONSIDERED 01/15/2009			
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